

Amendments to the Specification

Throughout the application papers, original Declaration excepted, cancel the title and insert the correct title --PRODUCTION OF MICROELECTROMECHANICAL SYSTEMS (MEMS) USING THE HIGH TEMPERATURE SILICON FUSION BONDING OF WAFERS--.

Please substitute the enclosed substitute specification in place of the specification as filed. Per 37 CFR 1.125, a marked-up copy of the substitute specification is enclosed in which all added text is underlined and deleted text is struck through. No new matter is included. Support for the changes therein is included in the Remarks section of this Amendment.